IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Takashi WATANABE et al.

Art Unit: 2818

Application Number: 10/823,729

Examiner: David Vu

Filed: **April 14, 2004**

Confirmation Number: 5344

For:

SEMICONDUCTOR DEVICE FABRICATION METHOD

Attorney Docket Number:

042341

Customer Number:

38834

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP: Amendment Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

June 25, 2009

Sir:

In response to the Office Action dated March 5, 2009, whose period for response is hereby petitioned for extension by one (1) month to July 5, 2009 (a Sunday), kindly amend the above-identified application as set forth below. In view of the same as well as the following remarks, kindly reconsider and further examine the application.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.